

Notice of References Cited

Application/Control No.

10/705,698

Applicant(s)/Patent Under
Reexamination
CHENG ET AL.

Examiner

Michael G. Miller

MGM

Art Unit

1792

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,319,674 B1	11-2001	Fulcrand et al.	435/7.1
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Klank et al; "CO2-laser micromachining and back-end processing for rapid production of PMMA-based microfluidic systems", 17 Sep 2002, The Royal Society of Chemistry, Lab on a Chip 2 2002(2), 242-246
	V	Henry et al; "Surface Modification of Poly(methyl methacrylate) Used in the Fabrication of Microanalytical Devices", 27 Sep 2000; American Chemical Society; Analytical Chemistry 72(21); 5331-5337
	W	McMurry; "Organic Chemistry"; 1984; Brooks/Cole; 1st Edition pp 639-640
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.